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FIG. 1 (PRIOR ART)

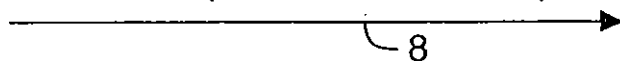


FIG. 2A

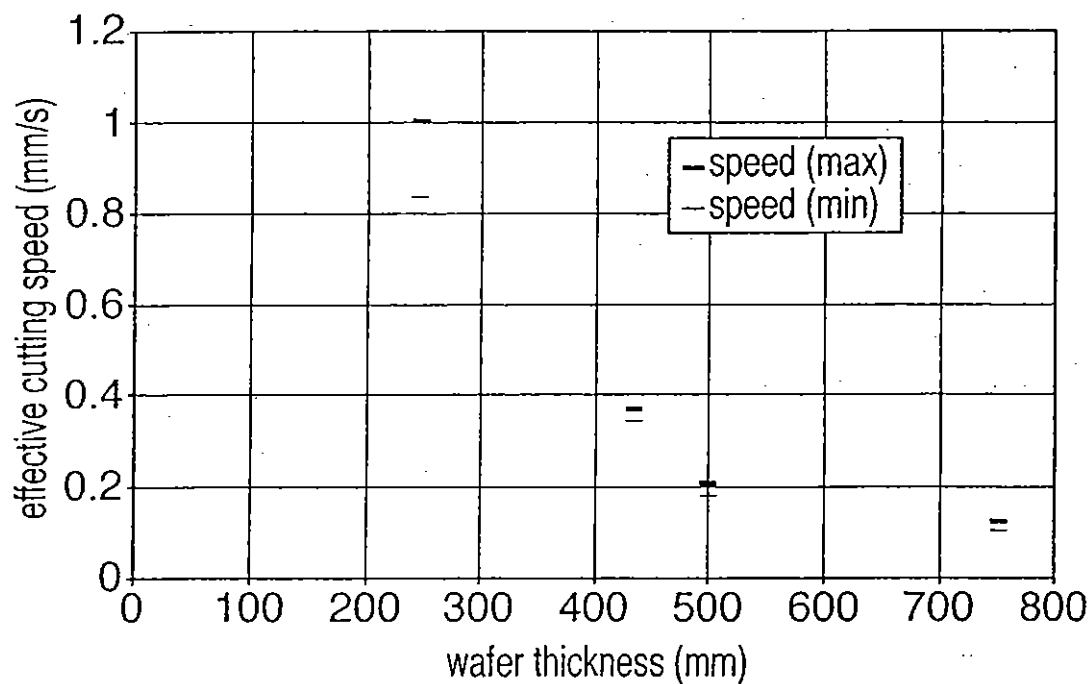
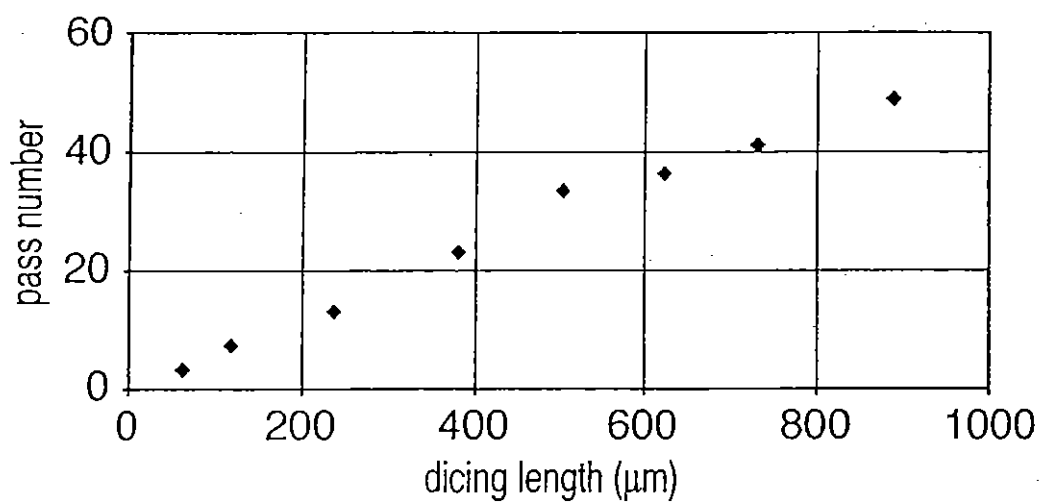
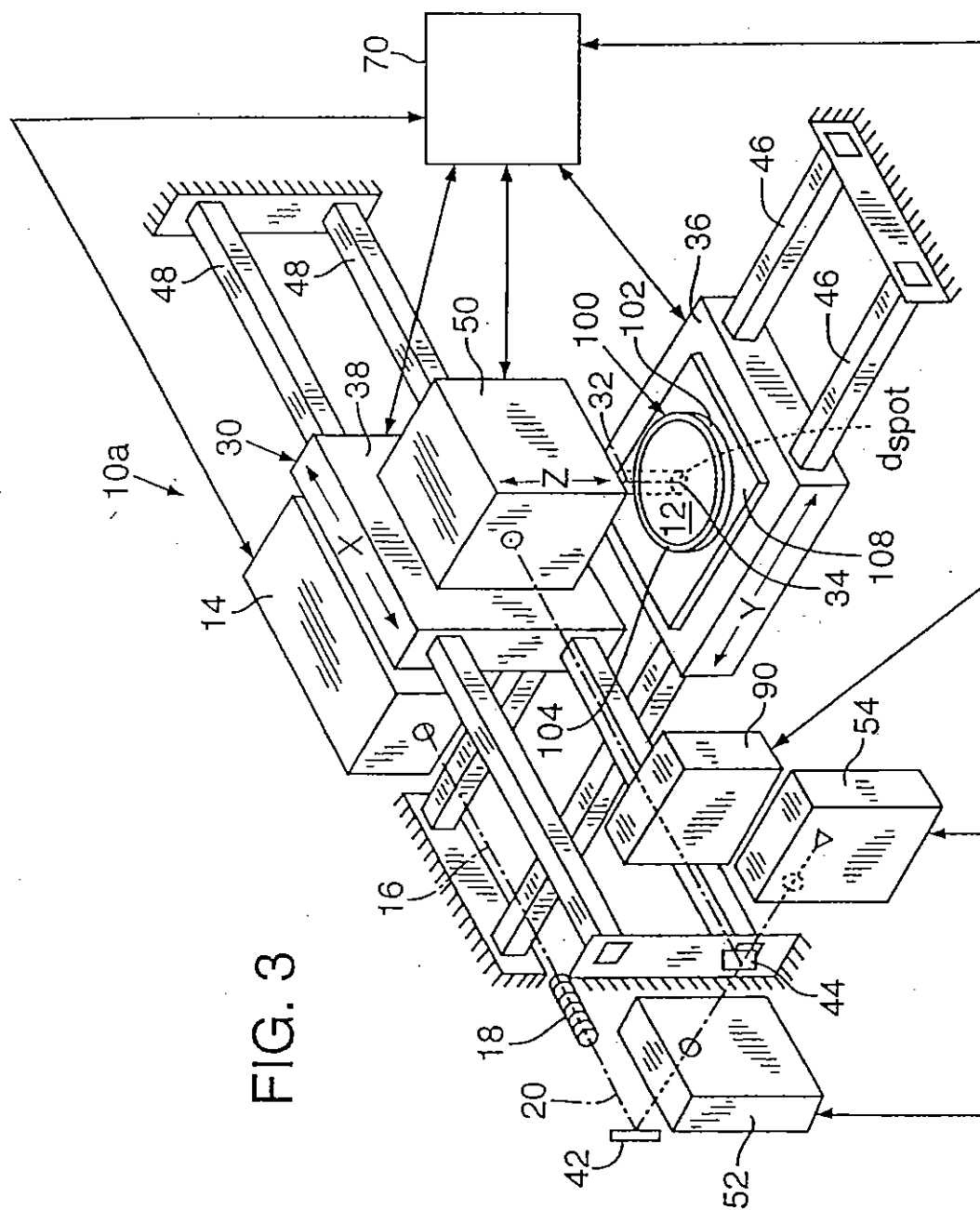


FIG. 2B



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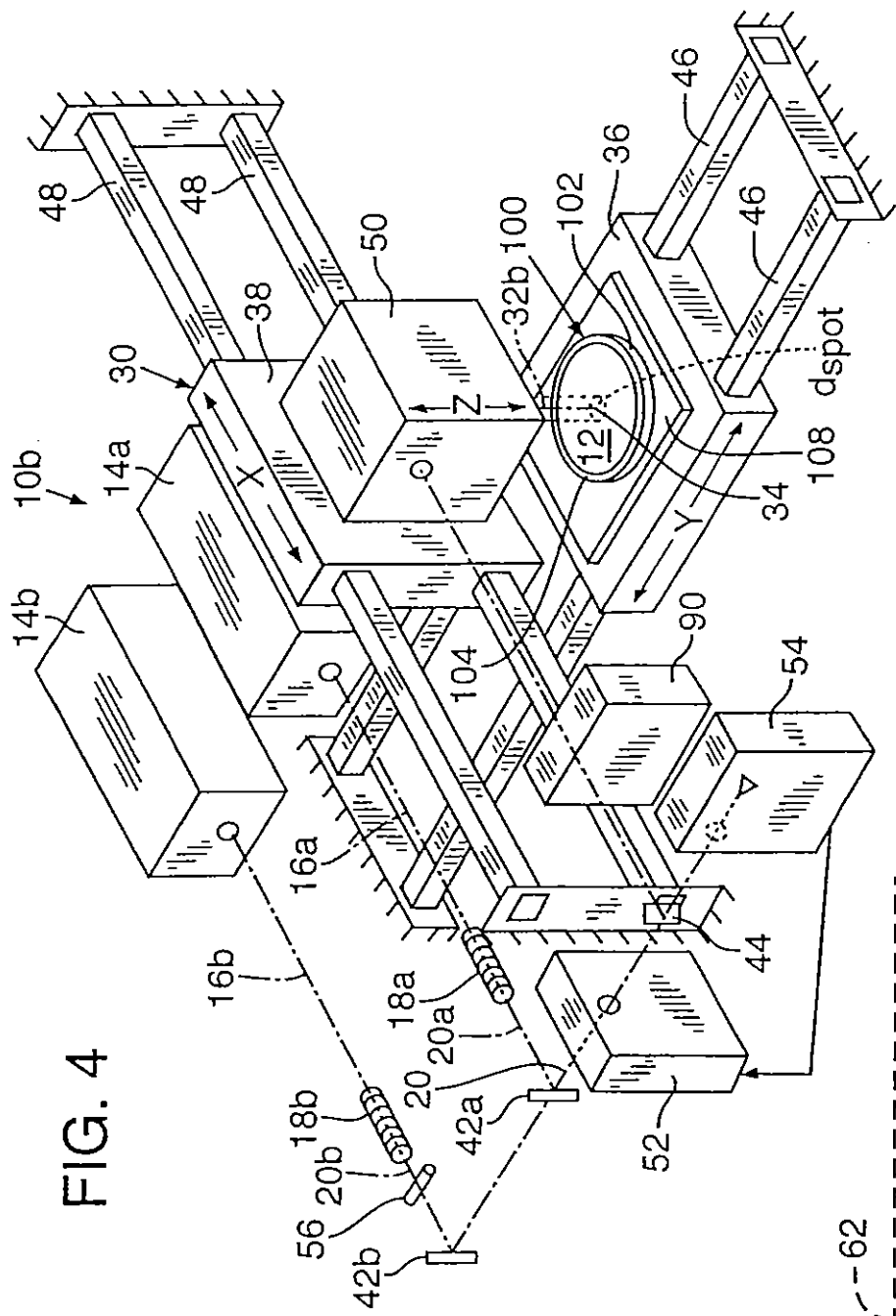


FIG. 4

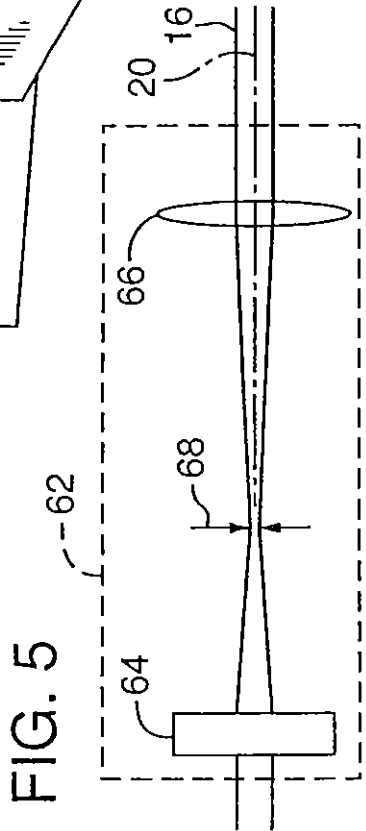
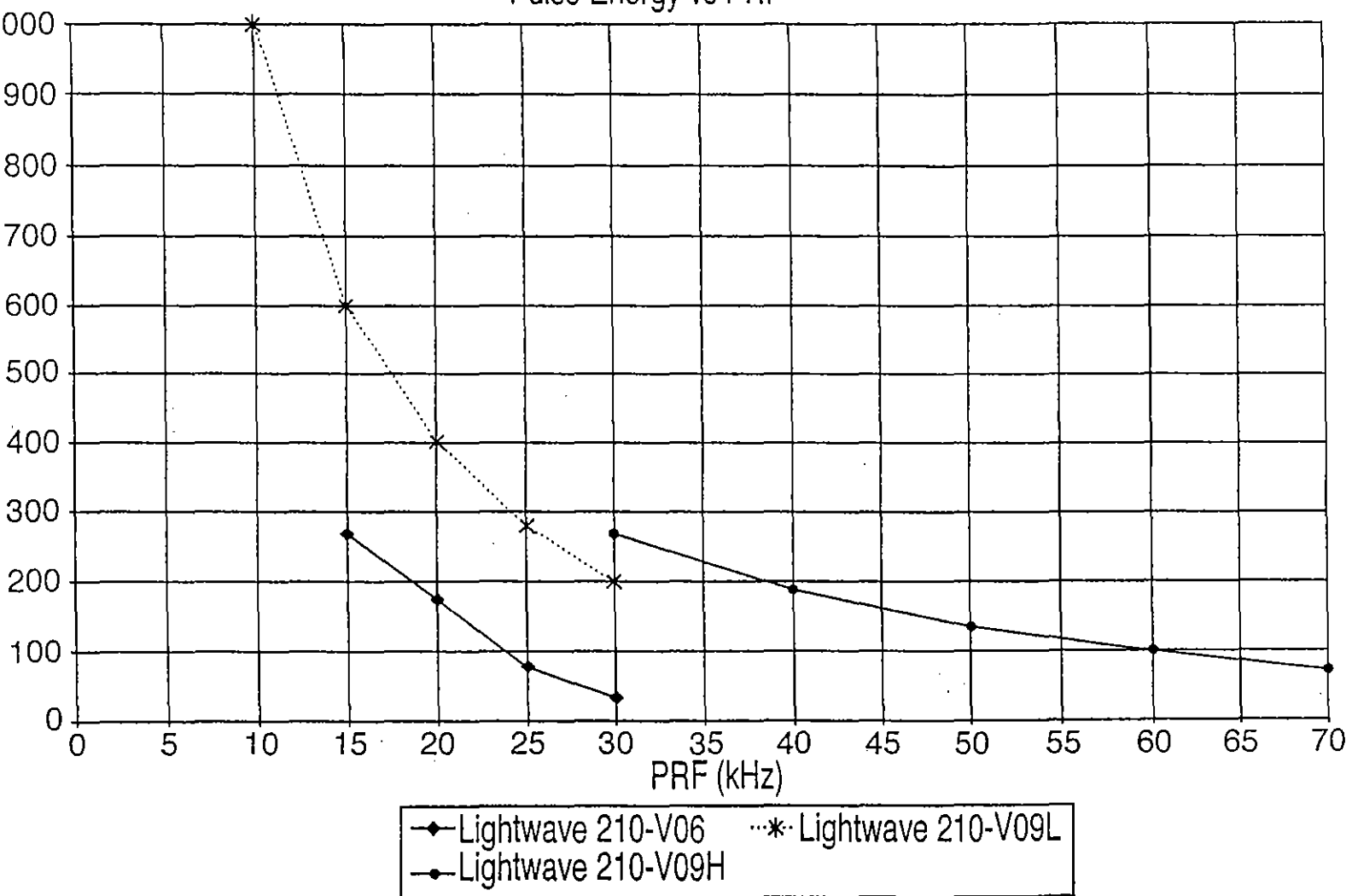


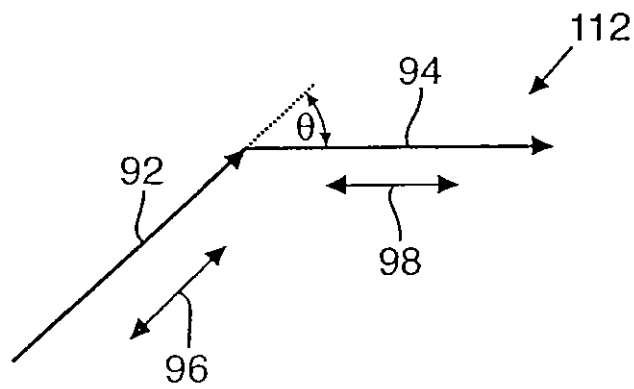
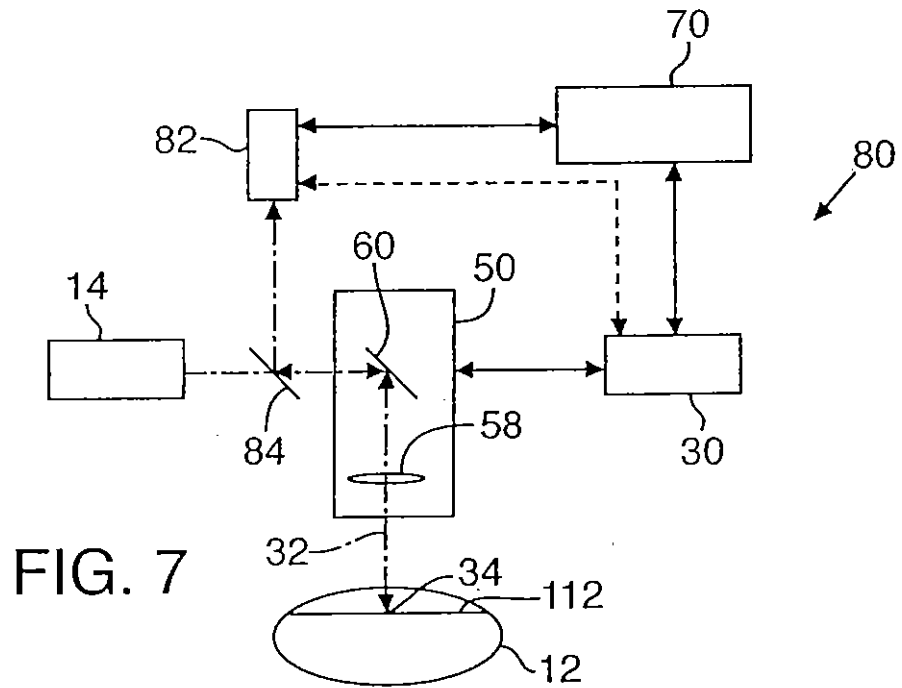
FIG. 5

FIG. 6

Advanced High Average Power Diode-Pumped 355 nm Lasers
Ablative Patterning of Semiconductors
Pulse Energy vs PRF



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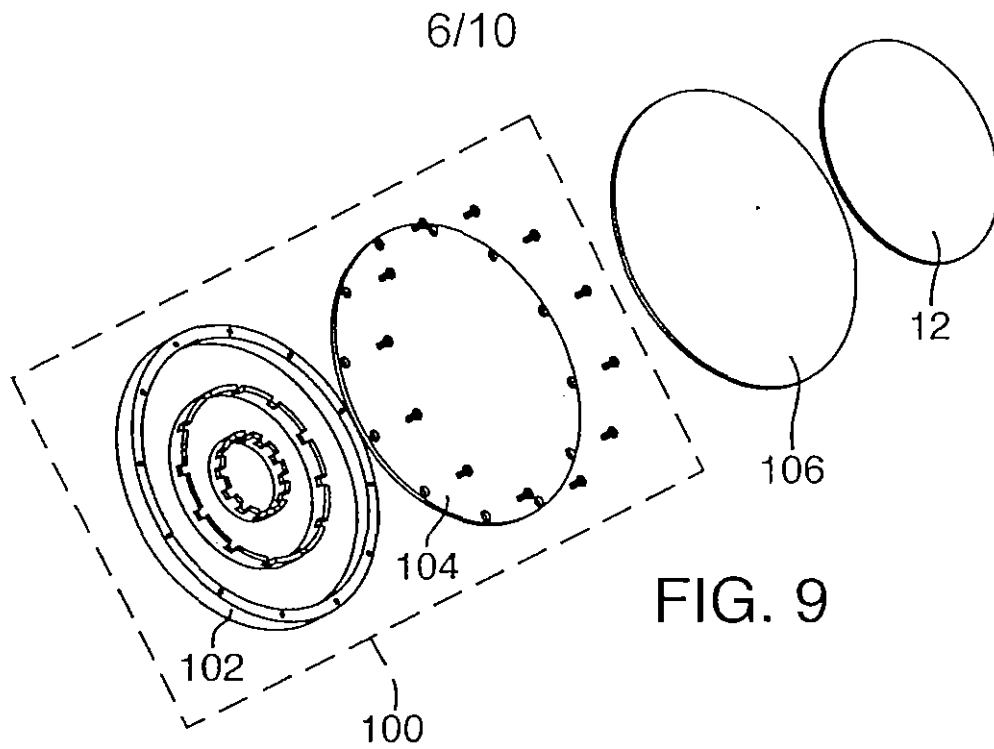


FIG. 10

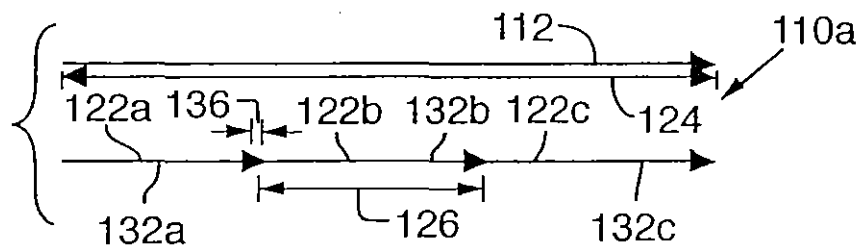
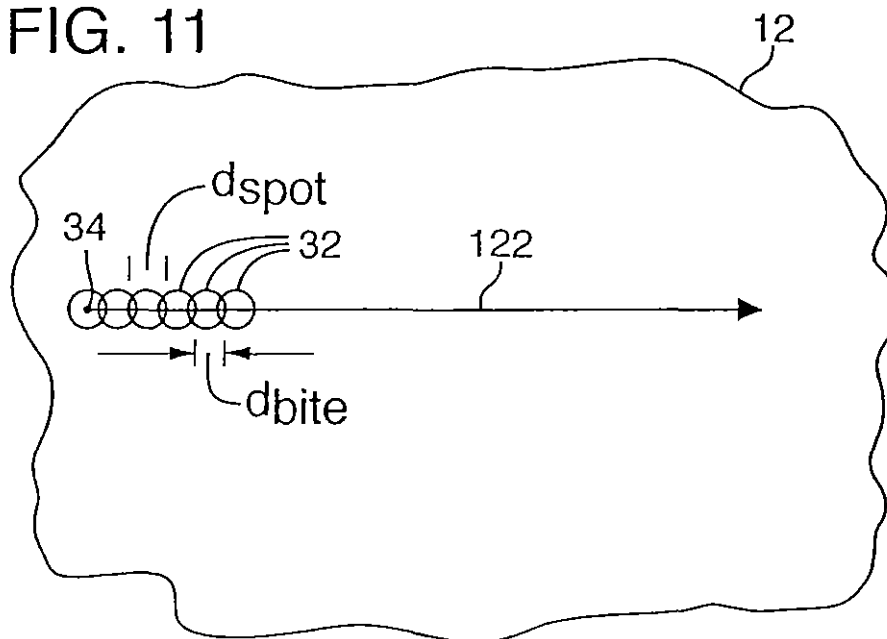
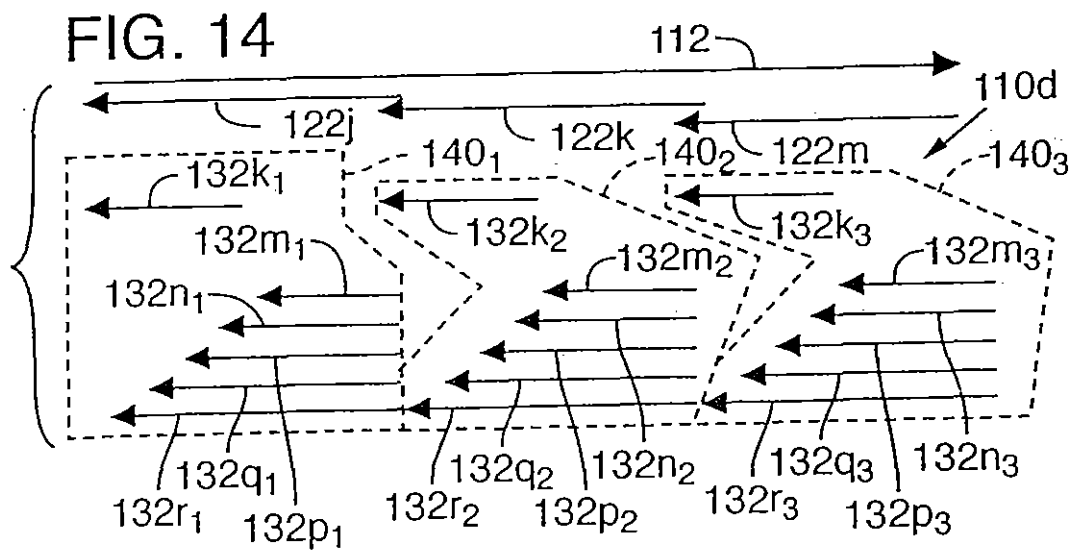
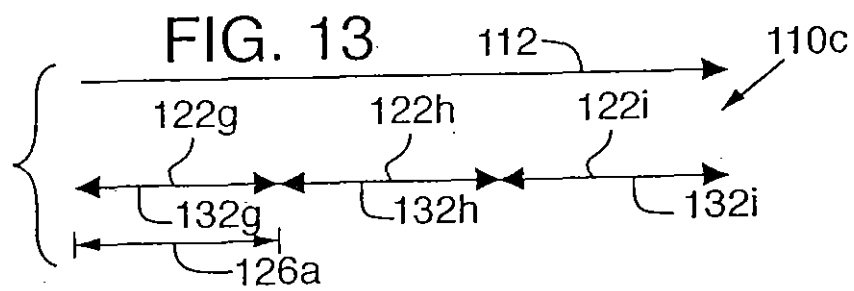
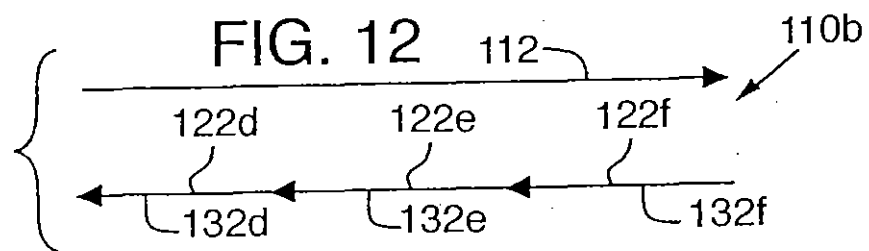


FIG. 11



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FIG. 15

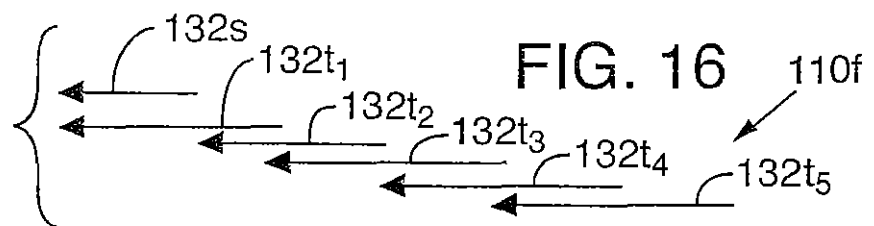
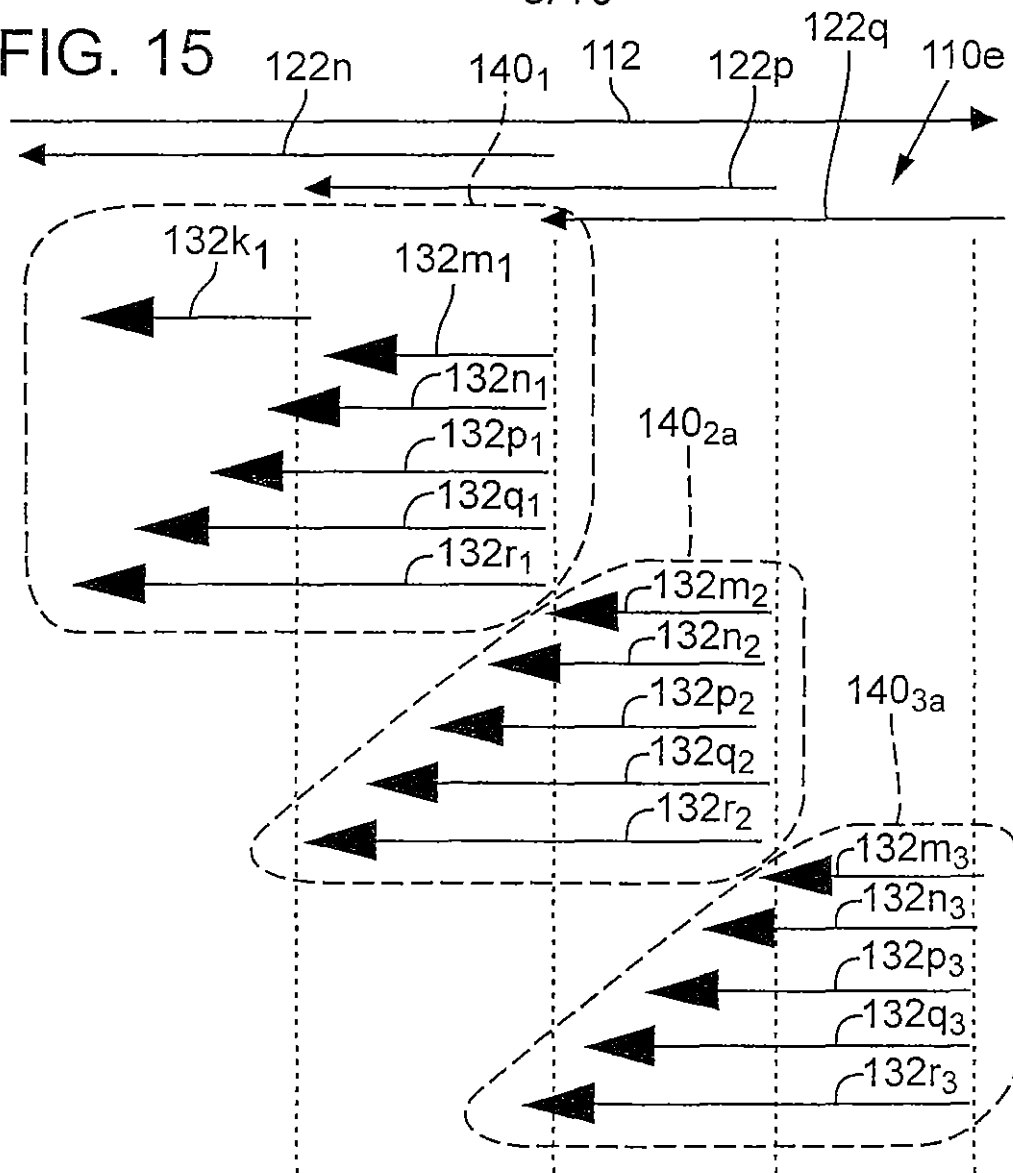
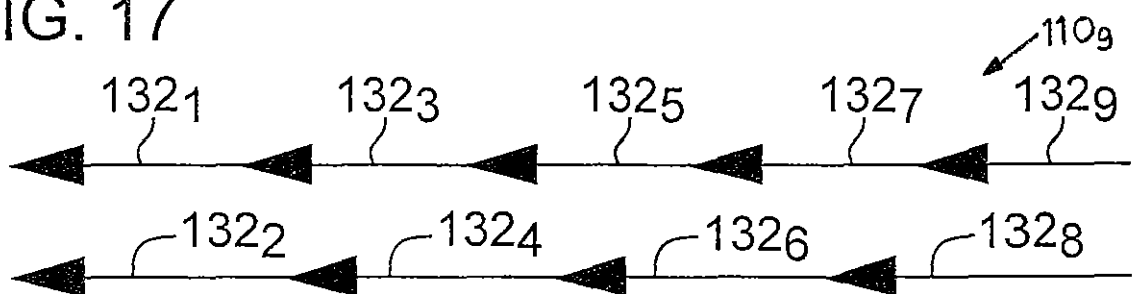
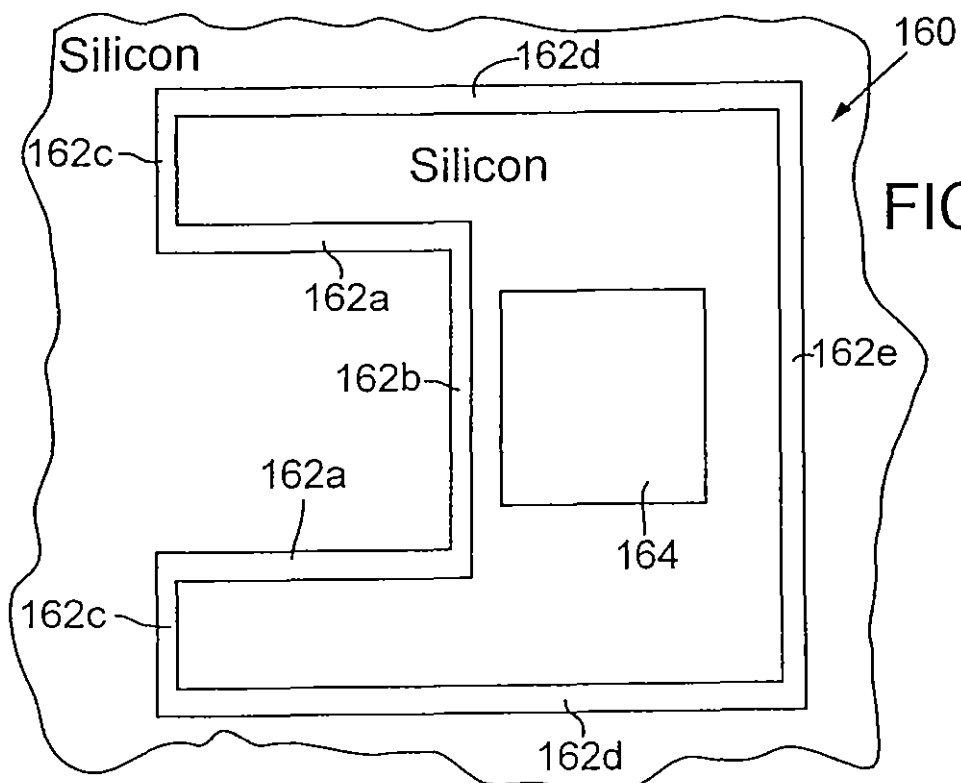
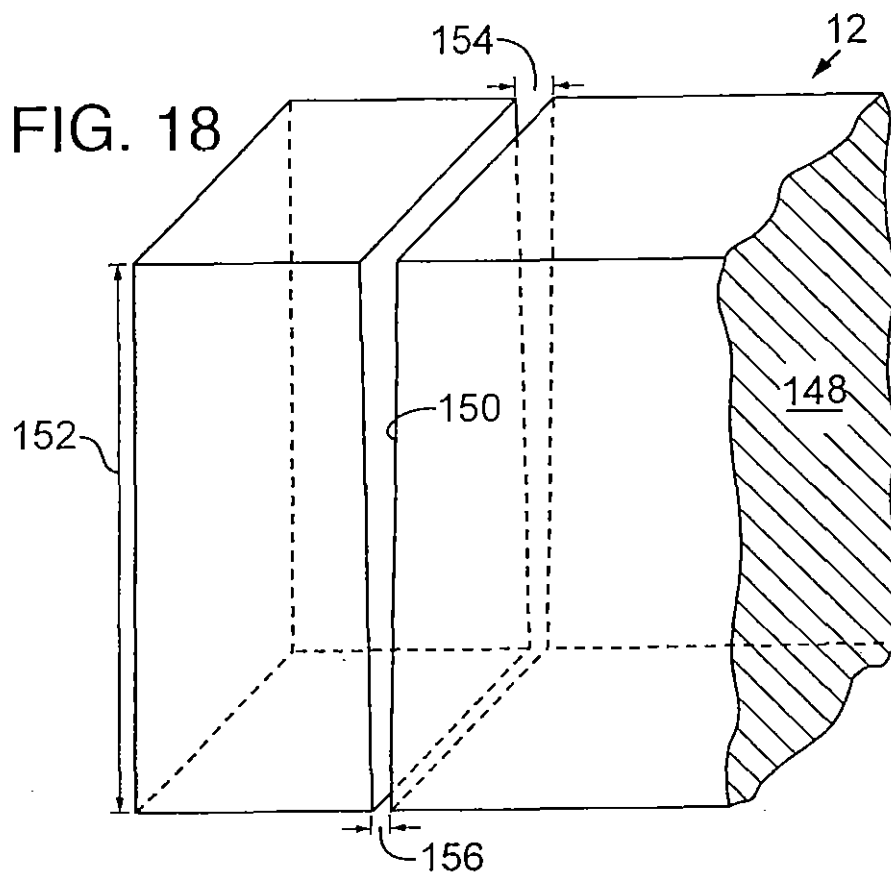


FIG. 16

FIG. 17



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FIG. 20

